



Investigation of Charge Multiplication in Silicon Strip Detectors 20th RD50 Workshop 30.05.- 01.06.2012

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Overview

- Introduction
 - Overview of sensor properties
- Qualification before and after irradiation
 - IV/CV measurement
 - Interstrip measurement
 - Bias resistance and coupling capacitance
- Charge collection before and after irradiation
 - CCE
 - Signal to noise ratio
 - Leakage current
- Summary

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# Geometry

Depth (d = 150 μm, 305 μm, 675 μm)

**RD 50:** Sensor Properties (p-Type)

- Width/pitch (0.075 < w/p < 0.75)
- Interstrip
- Active area: 10.18 mm x 11.76 mm
- Processing
  - Diffusion time
  - Implantation energy

## Irradiation

- Irradiation with protons and/or neutrons
- Variation of fluence

# Annealing time









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# **RD 50: Selected Sensors (p-Type)**

# Geometry

- Depth (d = 150 μm, 305 μm, 675 μm)
- Width/ pitch (0.075 < w/p < 0.75)</p>
- Interstrip
- Active area: 10.18 mm x 11.76 mm
- Processing
  - Diffusion time
  - Implantation energy
- Irradiation
  - Irradiation with protons and/or neutrons
  - Variation of fluence (1*10¹⁵, 5*10¹⁵, 1*10¹⁶ n_{eq}/cm²)

# Annealing time









### **Irradiation with Protons**

(a) 1*10 ¹⁵ n _{eq} /cm ²	Status	(b) 5*10 ¹⁵ n _{eq} /cm ²	Status	(c) 1*10 ¹⁶ n _{eq} /cm ²	Status
p100_w70_a	completed	p100_w70_b	completed	p100_w70_c	Strip scan
p100_w33_a	completed	p100_w33_b	completed	p100_w33_c	Strip scan
p100_w10_a	completed	p100_w10_b	completed	p100_w10_c	Strip scan
p80_w60_a	completed	p80_w60_b	Strip scan		
p80_w25_a	completed	p80_w25_b	completed		
p80_w6_a	completed	p80_w6_b	Strip scan		

- p100_w70_a: pitch 100µm, width 70µm, a: fluence F= 1*10¹⁵ n_{eq}/cm²
- Depth: 305µm
- Choose different fluences
- Irradiation with protons in Karlsruhe (23MeV protons)
- Irradiation with neutrons in Ljubljana (finished and ready to measure)
- Standard processing: no change of diffusion time and implantation energy

# Qualification before and after irradiation with protons: CV-measurement





# Qualification before and after irradiation with protons: IV-measurement





# Qualification before and after irradiation with protons: interstrip-measurement





### Qualification before and after irradiation with protons: coupling capacitance & bias resistance





p100-sensors

- Coupling capacitance CC
- CC: 2-2.5 (pF/cmµm) before and after irradiation

- Bias resistance R_{Bias}
- After irradiation R_{Bias} increases about 30%
- R_{Bias} higher with increasing



# **Setup and Annealing**

#### **Annealing**

temperature (°C)	60	80	80	80	80
time (min)	76	15	30	60	60
sum (days@21°C)	14.7	41.8	119.9	324	528

#### **Measurement**

- ALiBaVa-Measurement
- ⁹⁰Sr source
- Cuts
  - Seed: S/N > 5
  - Neighbors: S/N > 2
- Temperature: -20°C
- Voltage: 150V 1000V in 50V steps

- After each annealing step, a voltage ramp has been measured
- After last step: only four voltage values have been measured
- CCE
- Signal to noise ratio
- Leakage current



# **Measurement Results**

# Pitch = $100 \ \mu m$

## p100_w70_a: Complete Measurement





CCE



ALiBaVa measurement

- T= -20°C
- 100'000 Trigger
- Landau-Gauß-Fit

# Charge Collection Efficiency (CCE), Pitch=100µm







- no Charge Multiplication recognizable
  - 10¹⁵ n_{eq}/cm²: signal increases after short annealing time (beneficial annealing) and after long annealing time signal decreases (reverse annealing)
- 5*10¹⁵ n_{eq}/cm²: only small dependence of charge collection on annealing time

Histogram:  $1*10^{15} n_{eq}/cm^2 vs. 5*10^{15} n_{eq}/cm^2$ 



# Signal to Noise (s/n)





No difference between course of signal/noise and CCE



5*10¹⁵ n_{eq}/cm²: small value, sometimes below limit of s/n = 5



p100_w10 @ -20°C





### Leakage current



p100_w10 @ -20°C 7.000 6.000 5.000 5.000 4.000 3.000 2.000 → 300V, 10¹⁵
 600V, 10¹⁵ ◆900V, 10¹⁵ ◆900V, 5*10¹⁵  $\diamond$ 0 200 300 600 100 400 5**0**0 0 annealing time [d]

- Leakage current decreases with annealing time (as expected)
- Leakage current increases with higher fluence and smaller w/p value



# **Measurement Results**

# Pitch = $80 \mu m$



repeat measurement

0

300

400

500

annealing time[d]

600

# Charge Collection Efficiency (CCE), pitch 80 µm





## **Charge effect**







## Signal to Noise (s/n)





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### Leakage current







## Summary

- Increased charge collection for a short duration at high voltage (900V) and a fluence of 10¹⁵ n_{eq}/cm²
  - Signal to noise and leakage current also increase for a short time
  - This effect has to be understood (perhaps more measurement with Edge -TCT)
- No Charge Multiplication at a fluence 5*10¹⁵ n_{eq}/cm² so far
- Next step: measuring samples after neutron irradiation
- Dependence on processing will be investigated
  - Sensors already measured in non irradiated condition

# Thanks for your attention



### **Backup**

# **Qualification before and after irradiation with protons: interstrip resistance** R_{int}





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# Qualification before and after irradiation with protons: interstrip capacitance C_{int}





# Qualification before and after irradiation with protons: bias resistance R_{Bias}





# Qualification before and after irradiation with protons: coupling capacitance CC





Histogram:  $1*10^{15} n_{eq}/cm^2 vs. 5*10^{15} n_{eq}/cm^2$ 

